	Application No.	Applicant(s)	
•	10/516,742	LEE, SUK HUN	
Notice of Allowability	Examiner	Art Unit	
	Cheung Lee	2812	
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT I of the Office or upon petition by the applicant. See 37 CFR 1.31	pears on the cover sheet w. S (OR REMAINS) CLOSED i 5) or other appropriate comm RIGHTS. This application is	ith the correspondence address n this application. If not included unication will be mailed in due course. The	HIS itiative
1. \boxtimes This communication is responsive to <u>the Amendment file</u>	<u>d on 11/21/07</u> .		•
2. X The allowed claim(s) is/are 1-18.		·	
 3. Acknowledgment is made of a claim for foreign priority of a) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 	ve been received.		
3. Copies of the certified copies of the priority d	ocuments have been receive	d in this national stage application from t	he
International Bureau (PCT Rule 17.2(a)).			
* Certified copies not received:			
Applicant has THREE MONTHS FROM THE "MAILING DATE noted below. Failure to timely comply will result in ABANDON THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		e a reply complying with the requirements	5
4. A SUBSTITUTE OATH OR DECLARATION must be sub INFORMAL PATENT APPLICATION (PTO-152) which gi			F
5. CORRECTED DRAWINGS (as "replacement sheets") me	ust be submitted.		
(a) \square including changes required by the Notice of Draftspe		w (PTO-948) attached	
1) hereto or 2) to Paper No./Mail Date			
(b) ☐ including changes required by the attached Examine Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR)			
each sheet. Replacement sheet(s) should be labeled as such in	the header according to 37 C	FR 1.121(d).	
 DEPOSIT OF and/or INFORMATION about the dep attached Examiner's comment regarding REQUIREMEN' 			
	•		
Attachment(s)	E □ Nation of I	oformal Potent Application	•
 Notice of References Cited (PTO-892) Notice of Draftperson's Patent Drawing Review (PTO-948) 		nformal Patent Application Summary (PTO-413),	
	Paper No	/Mail Date	
 Information Disclosure Statements (PTO/SB/08), Paper No./Mail Date 	7. 🔲 Examiner's	Amendment/Comment	
4. Examiner's Comment Regarding Requirement for Deposit of Biological Material	•	Statement of Reasons for Allowance	
	9. 🔲 Other	-2 - 111 Lun	,
		Market John	-
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Application/Control Number:

10/516,742 Art Unit: 2812

DETAILED ACTION

Notice to Applicant ■ Notice to Applicant Notice to Appli

Applicant's Amendment and Response to the Office Action mailed on August 24,
 2007 has been entered and made of record.

Response to Amendment

2. In view of applicant's amendments and arguments filed on November 21, 2007, the rejections of claims 1-7, 10-11 and 16-18 under 35 U.S.C. 103(a) as stated in the indicated Office Action have been withdrawn.

Terminal Disclaimer

3. The terminal disclaimers filed on November 21, 2007 disclaiming the terminal portion of any patent granted on this application which would extend beyond the expiration date of any patent granted on Application Number 10/517818 and Pat. 7193236 have been reviewed and are accepted. The terminal disclaimers have been recorded.

Reason for Allowance

4. Claims 1-18 are allowed.

The following is an examiner's statement of reasons for allowance: Claims 1, 4, 7 and 16-18 recite growing a GaN-based buffer layer on a substrate, wherein said GaN-

Application/Control Number:

10/516,742 Art Unit: 2812

based buffer layer is a three-layered structure $Al_yIn_xGa_{1-(x+y)}N/In_xGa_{1-x}N/GaN$ where $0 < x \le 1$ and $0 \le y \le 1$.

Claims 8, 12 and 14 recite wherein the GaN-based buffer layer is grown in an MOCVD equipment at a temperature of $500 - 800^{\circ}$ C and in a thickness $50-800^{\circ}$ A by introducing sources of TMAGa, TMIn and TMAI and a gas of NH₃ at the same time while supplying carrier gases of H₂ and N₂.

These features in combination with the other elements of the claims are neither disclosed nor suggested by the prior art of record.

Claims 2-3, 5-6, 9-11, 13 and 15 variously depend from claim 1, 4, 7, 8 and 12, so they are allowed for the same reason.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Cheung Lee whose telephone number is 571-272-5977. The examiner can normally be reached on Monday through Friday from 8:30AM to 5:00 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Michael Lebentritt can be reached on 571-272-1873. The fax phone

Application/Control Number:

10/516,742

Art Unit: 2812

Page 4

number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

Cheung Lee

December 6, 2007